



B

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Moon, et al.

Serial No.: 10/025,144

Confirmation No.: 5051

Filed: December 18, 2001

For: Method and Apparatus for  
Polishing Metal and  
Dielectric Substrates

§  
§  
§  
§  
§  
§  
§  
§  
§  
§  
§

Group Art Unit: 2813

Examiner: Stephen W. Smoot

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATE OF MAILING 37 CFR 1.8	
I hereby certify that this correspondence is being deposited on <u>10/21</u> , 2003 with the United States Postal Service as First Class Mail in an envelope addressed to: Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.	
Date <u>10/21/03</u>	Signature <u>Keith M. Tackett</u>

SUBMISSION OF FORMAL DRAWINGS

Attached please find attached (6) sheets of formal drawings, with gummed labels on the back identifying the application for which they are submitted. The Examiner is requested to substitute these formal drawings for the informal drawings used during the prosecution of the subject patent application.

Any comparison fee should be charged to Deposit Account No. 20-0782/AMAT/5999/KMT. Two copies of this document are enclosed for your convenience. If any additional informalities are identified by the Examiner, please contact the undersigned attorney at 713/623-4844.

Respectfully submitted,

Keith M. Tackett  
Registration No. 32,008  
MOSER, PATTERSON & SHERIDAN, L.L.P.  
3040 Post Oak Blvd. Suite 1500  
Houston, TX 77056  
Telephone: (713) 623-4844  
Facsimile: (713) 623-4846  
Attorney for Applicant(s)